



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 20, 2026	
IGI Report Number	LG765632726
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	15.24 X 9.07 X 5.55 MM

GRADING RESULTS

Carat Weight	5.00 CARATS
Color Grade	E
Clarity Grade	VS 1

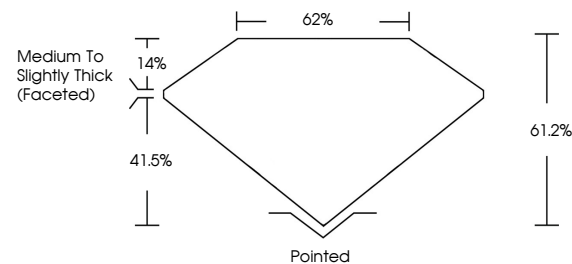
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG765632726

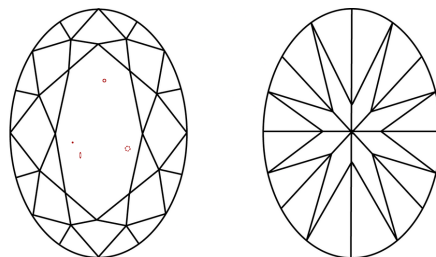
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG765632726
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

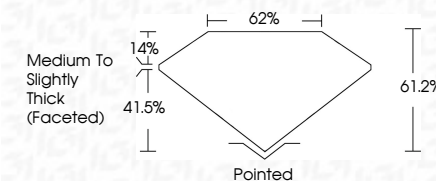
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www.igi.org

January 20, 2025	GL Report No. LG76562726	5.00 CARATS	E
DIAM BRILLANT	15.5x9.7x 5.55 MM	VS 1	61.2%
		62%	
		Medium to Slightly Thick (Faceted)	
		Pointed	
		EXCELLENT	
		EXCELLENT	
		NONE	
		lg81 LG76562726	

Comments: This is a very poor diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA